

## **PATENT**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No.:

10/594,636

Group Art Unit:

1793

Filing Date:

September 28, 2006 Examiner:

Michael A. Marcheschi

Date: April 9, 2008

Applicant:

Yoshiharu OHTA et al.

Title:

SEMICONDUCTOR POLISHING COMPOSITION

Attorney Docket:

2691-000051/US

Customer Service Window Randolph Building

401 Dulany Street

Alexandria, VA 22314

**Mail Stop Amendment** 

## **REQUEST FOR RECONSIDERATION**

Sir:

This Request for Reconsideration is responsive to the October 10, 2007 Office Action, the statutory period for reply being extended to April 10, 2008, by the accompanying extension of time, the following remarks are respectfully submitted in connection with the above-identified application.

Listing of Claims begin on page 2 of this paper.

Remarks begin on page 5 of this paper.

	Claims remaining after Amendment		Highest number previously paid for		Present extra
Total	18	-	20	=	0
Independent	3	-	3	=	0

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